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CONFIRMATION NO. 7432

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|---|---|--|------------------------|-------------------------------------|
| SERIAL NUMBER 10/655,305 | FILING DATE 09/05/2003 RULE | CLASS 451 | GROUP ART UNIT 3723 | ATTORNEY DOCKET NO. SEC.1080 |
| APPLICANTS Yong-Sung Hong, Osan-City, KOREA, REPUBLIC OF; | | | | |
| ** CONTINUING DATA ***** <i>None SLM</i> | | | | |
| ** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 2002-64457 10/22/2002 <i>SLM</i> | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/28/2003 | | | | |
| Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged | <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>SLM</i> Examiner's Signature <i>SLM</i> Initials | STATE OR COUNTRY KOREA, REPUBLIC OF | SHEETS DRAWING 3 | TOTAL CLAIMS 5 INDEPENDENT CLAIMS 1 |
| ADDRESS 20987 VOLENTINE FRANCOS, & WHITT PLLC ONE FREEDOM SQUARE 11951 FREEDOM DRIVE SUITE 1260 RESTON , VA 20190 | | | | |
| TITLE CMP equipment for use in planarizing a semiconductor wafer | | | | |
| FILING FEE | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) | | |

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